

# Development of applications for CEC diagnostics line

- Temporal profile of the electron bunch. ~Ready.
- Finding of zero-crossing RF phase.
- Energy ( $dp/p$ ) spread. ~Ready.
- Emittance using multi-slit. To be tested.
- Time resolved emittance.

# Transverse Deflecting Cavity

It will convert the beam's longitudinal distribution to transverse distribution which is measurable

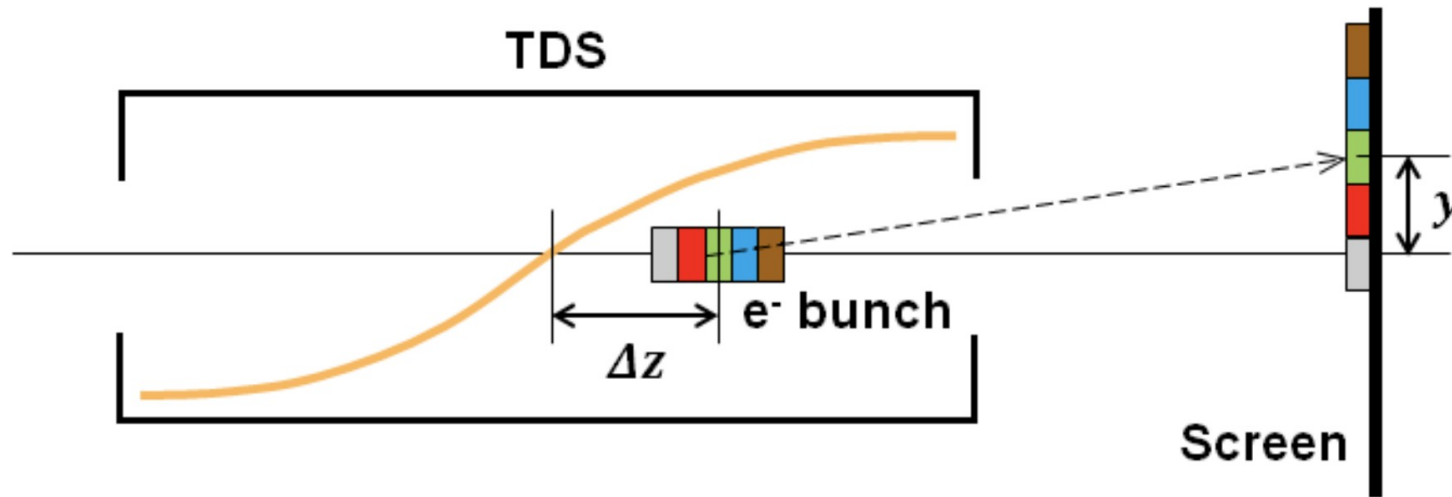


Table 1 key beam parameters of CEC 1.5nC operation

parameter	Symbol	Value	Unit
Beam size at yag without Deflecting cavity		~0.4	mm
Beta function at screen		0.1	m
Normalized rms emittance		~1.5	mm-mrad
Beam energy at deflector		14.5	MeV
Beam energy at screen		14.5	MeV
bunch length (edge to edge)		~30	ps

Table 2 Main parameters of 1.3GGHz TDS

parameter	Symbol	Value	Unit
RF deflector frequency	$\omega_{rf}$	1.3	GHz
RF deflector shunt impedance	$R_T$	~3.5	M $\Omega$
RF deflector unloaded quality factor	$Q$	9450- 10050	
RF deflector power	$P_0$	~10	KW
RF deflector maximum accelerating voltage	$V_0$	~ <0.26	MV

- \* resolution of <1ps (accurate to 1THz)
- \* measure the beam's longitudinal phase space info

# Conversion of image coordinate to time

If bunch length is much smaller than the RF wavelength:

$$d\theta = \frac{dy}{L} = \cos(\phi) \frac{V}{p} (\sin(\omega dt))$$

Where:

$dy$  is displacement on the YAG screen,

$L$  is deflecting base,

$V$  is the total transfer voltage of the cavity,

$\omega$  is angular frequency,

$p$  is momentum (eV/c),

$\phi$  is the RF phase of the cavity, for analysis it is assumed that  $\phi = 0$ .

# Temporal Profile of the Electron Bunch

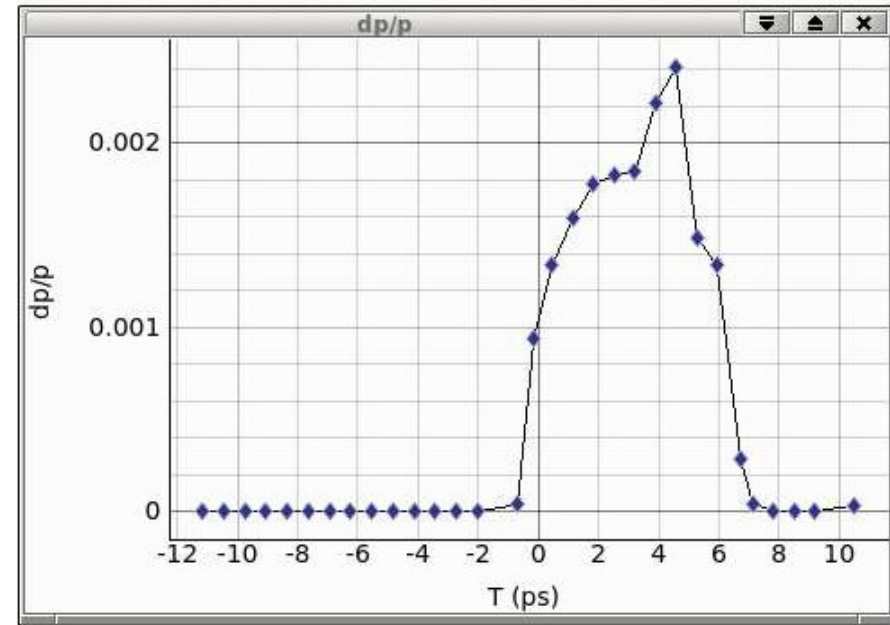
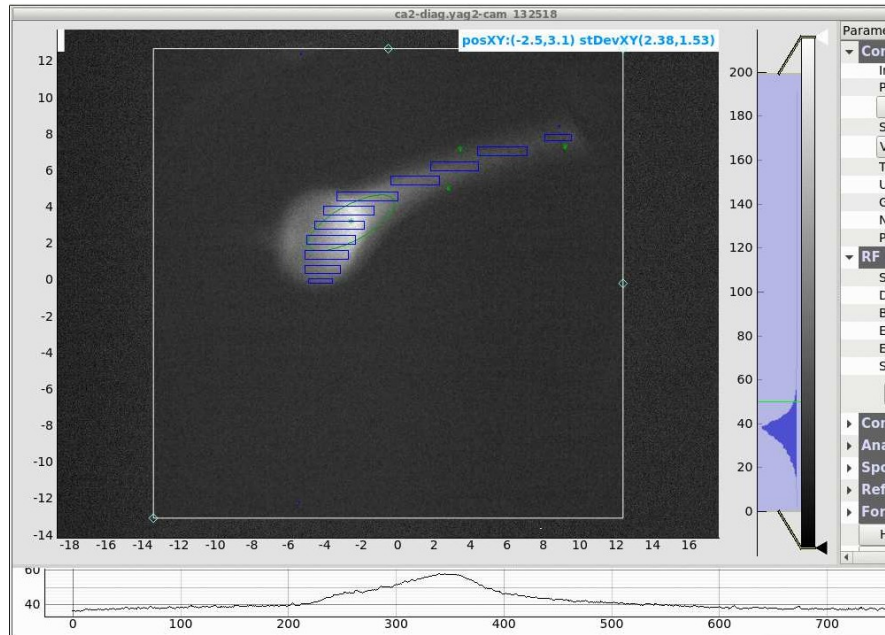
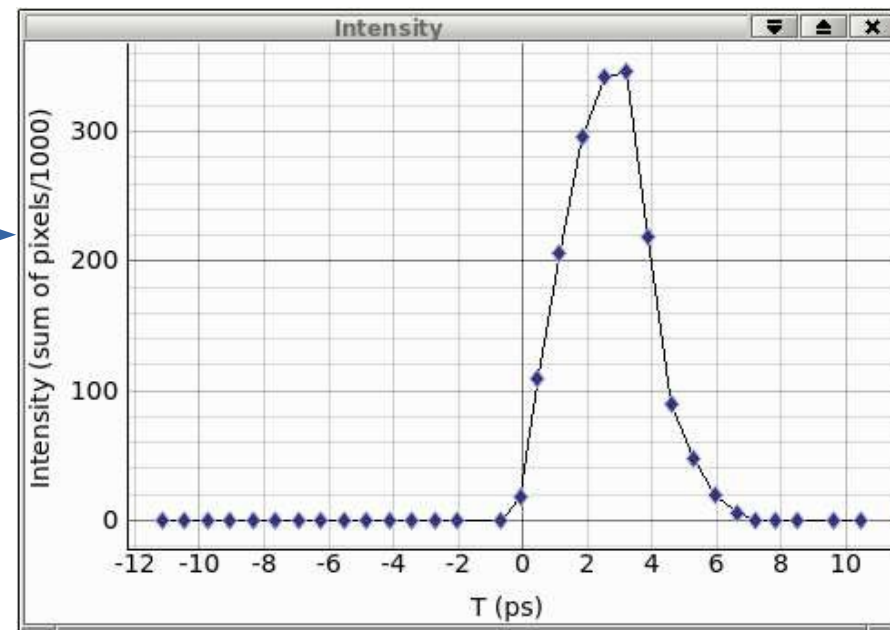
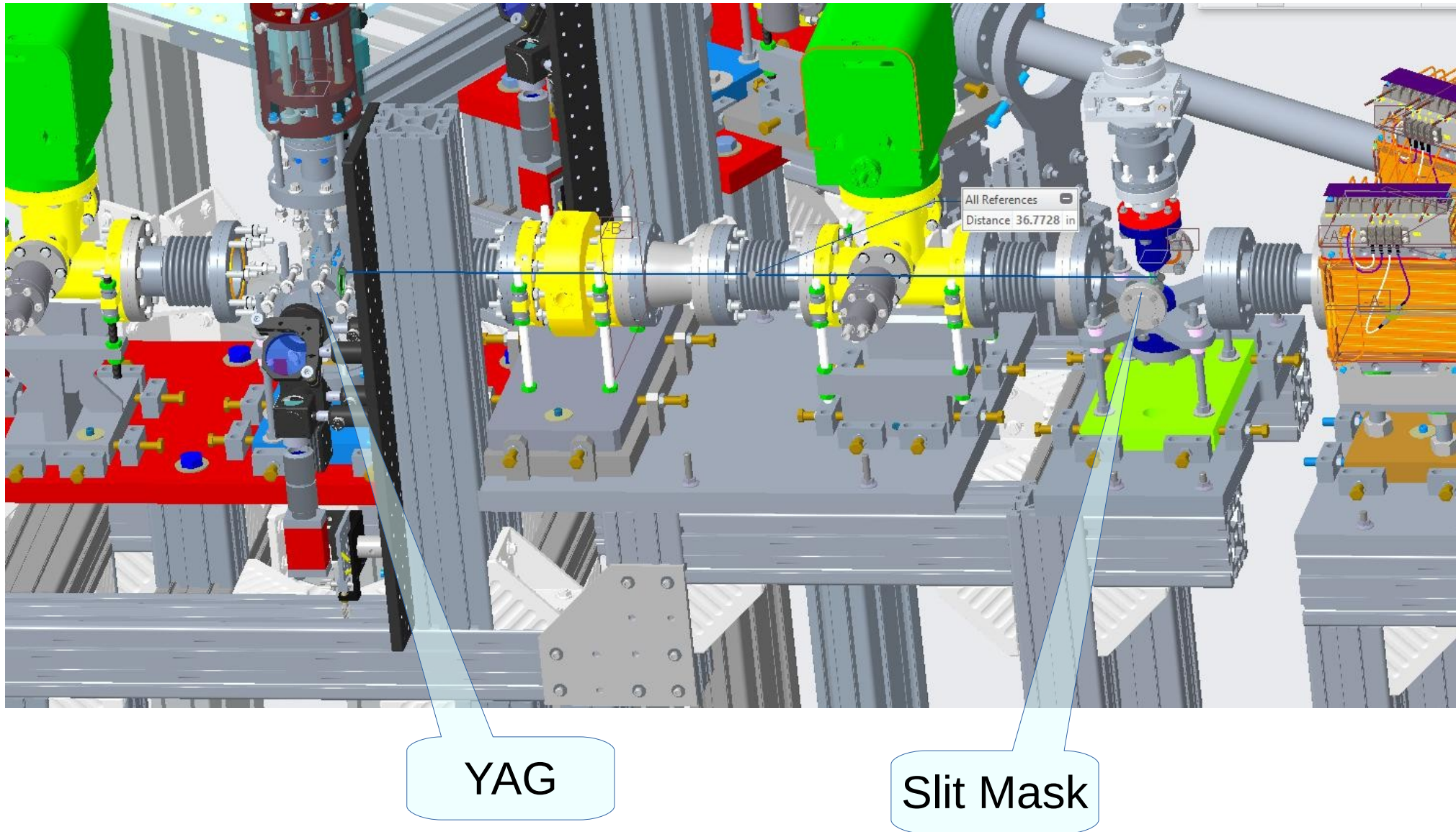


Image at CEC YAG screen downstream of deflecting cavity.

TODO:  
Normalize by bunch charge to show  
bunch current vs time

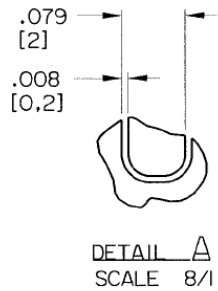
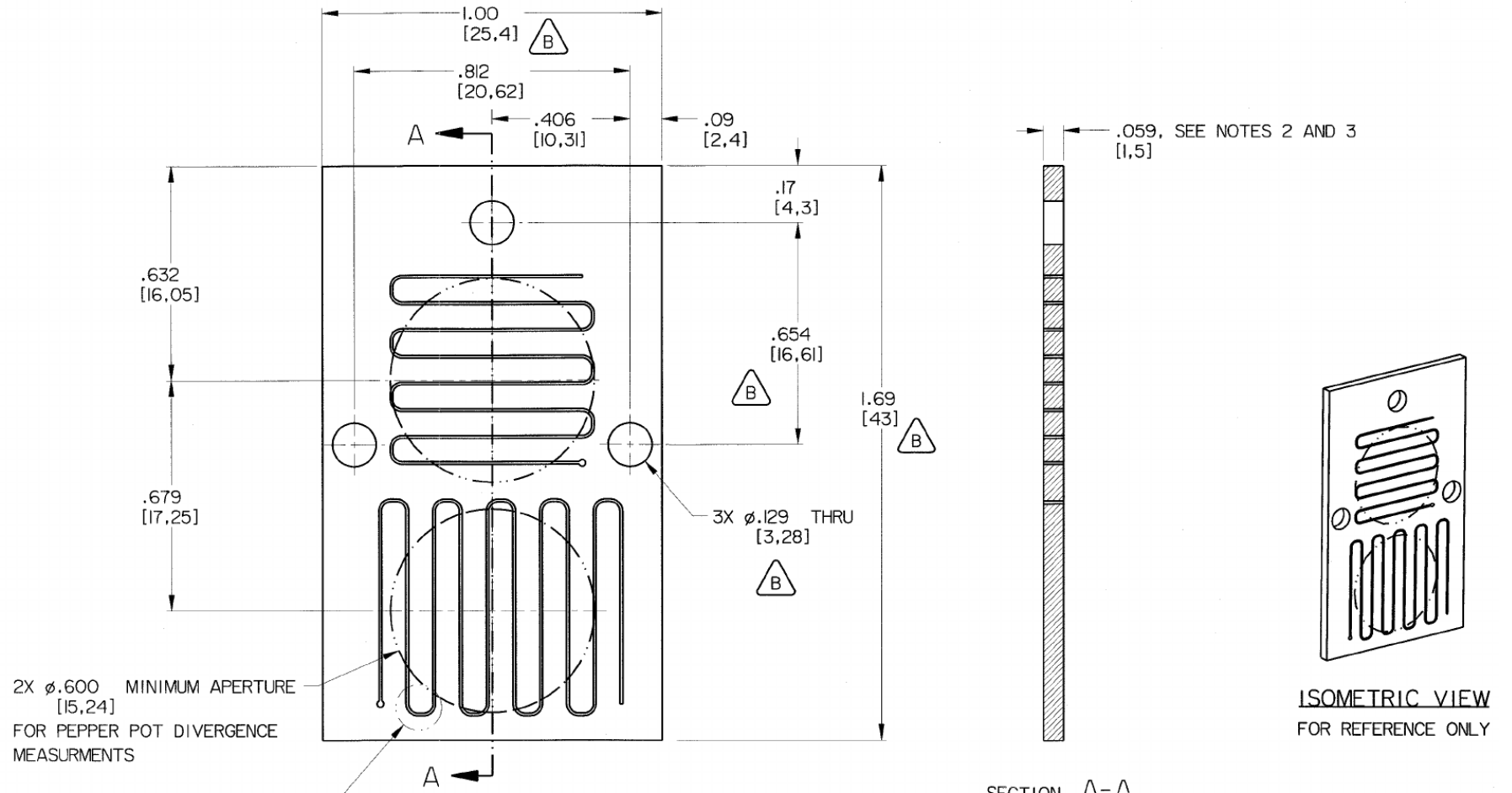


# Multi-slit Emittance Measurement



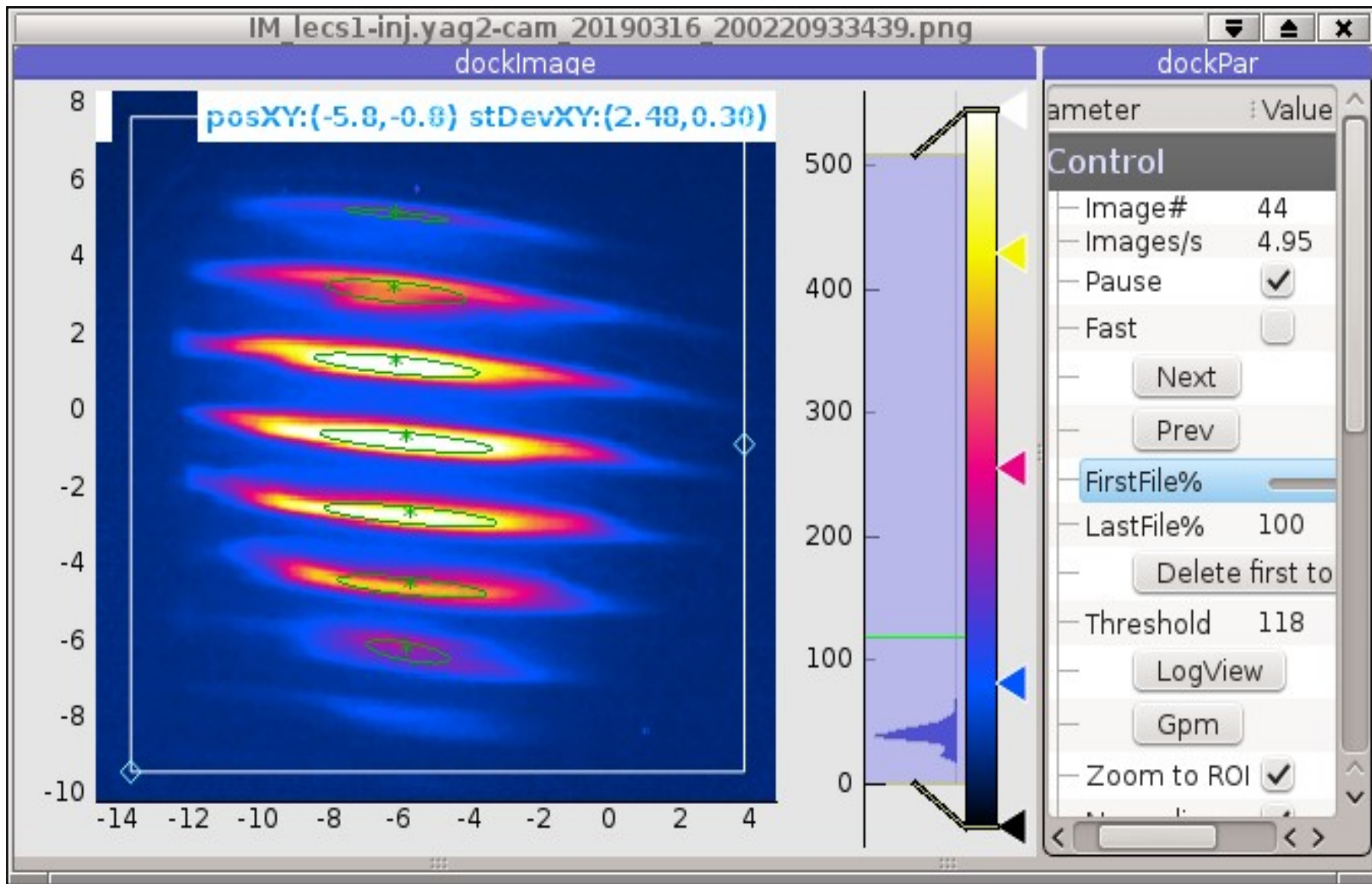


# Multi-slit Mask



		INTERPRET IN GENERAL ACCORDANCE WITH ANSI/ASME Y14.54M-1994		COLLIDER-ACCELERATOR DEPARTMENT BROOKHAVEN NATIONAL LABORATORY UPTON, N.Y. 11973	
		UNLESS OTHERWISE SPECIFIED		CeC PoP - PHASE ONE PEPPER POT ASSEMBLY MASK	
		DIMENSIONS ARE IN INCHES		DRAWING NUMBER: 0070M0001	
		DECIMAL TOLERANCES		SIZE C	
		.X ± .030		O.A. CATEGORY A-3	
		.XX ± .015		SCALE: 4/1	
		.XXX ± .005		WEIGHT: 0.1	
		ANGULAR TOLERANCE ±1°		SHEET 1	
0070M0008		125			
USED ON DRAWING NO.		FINISH			
QTY. PER ASSY:		BREAK SHARP EDGES			
APPLICATION		MAX. .03 MIN. .015			

# Multi-slit Emittance Application



YAG screen image downstream of the multi-slit mask at LEReC.

# Emittance Calculation for Multi-slit

Input parameters:

$i$  – beamlet index

$m_i$  – slit position on the mask

**$t$**  – slit width

$L$  – drift length

$\mathbf{w}_i$  – beamlet intensity

$\mathbf{x}_i$  – x-coordinate of the beamlet centroid

$\sigma_i$  – standard deviation of the beamlet, projected along its long axis

$$s_i = \sqrt{\sigma_i^2 - t^2/12}$$

Reduced  $\sigma_i$  due to finite slit width

$$N = \sum w_i$$

$$\bar{m} = \frac{1}{N} \sum w_i m_i$$

$$x'_i = \frac{1}{L} (x_i - m_i)$$

$$\overline{x'} = \frac{1}{N} \sum w_i x'_i$$

$$s^2(m) = \frac{1}{N} \sum w_i (m_i - \bar{m})^2$$

$$S^2(x') = \frac{1}{N} \sum w_i \left( \frac{s_i^2}{L^2} + (x'_i - \overline{x'})^2 \right) \quad (1)$$

$$\overline{xx'} = \frac{1}{N} \sum w_i m_i x'_i - \bar{m} \bar{x'} \quad (2)$$

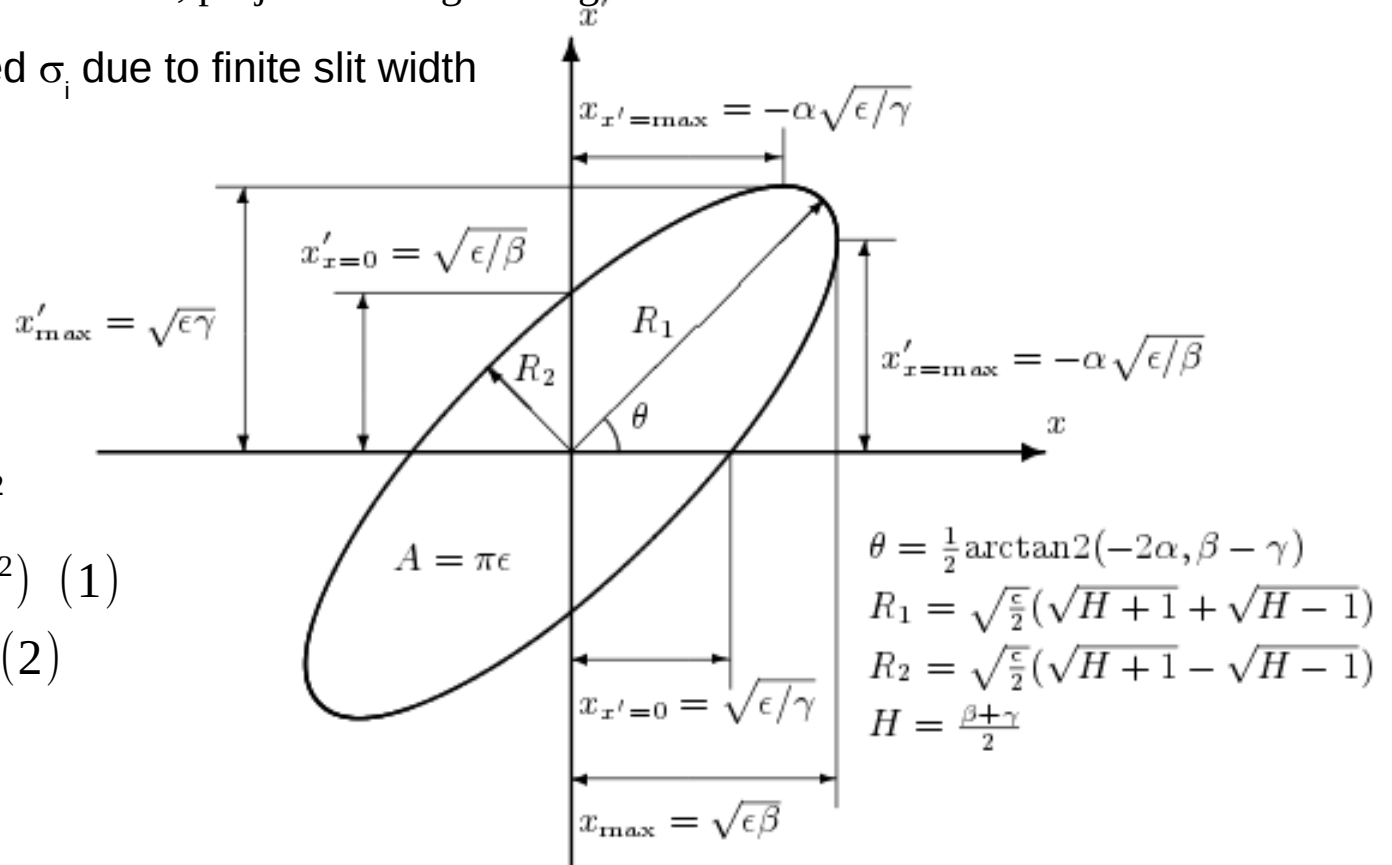
## Calculated Twiss parameters

$$\epsilon = \sqrt{(s^2(m)s^2(x') - (\overline{xx'})^2)} \quad (3)$$

$$\alpha = \frac{-\overline{xx'}}{\epsilon} \quad (4)$$

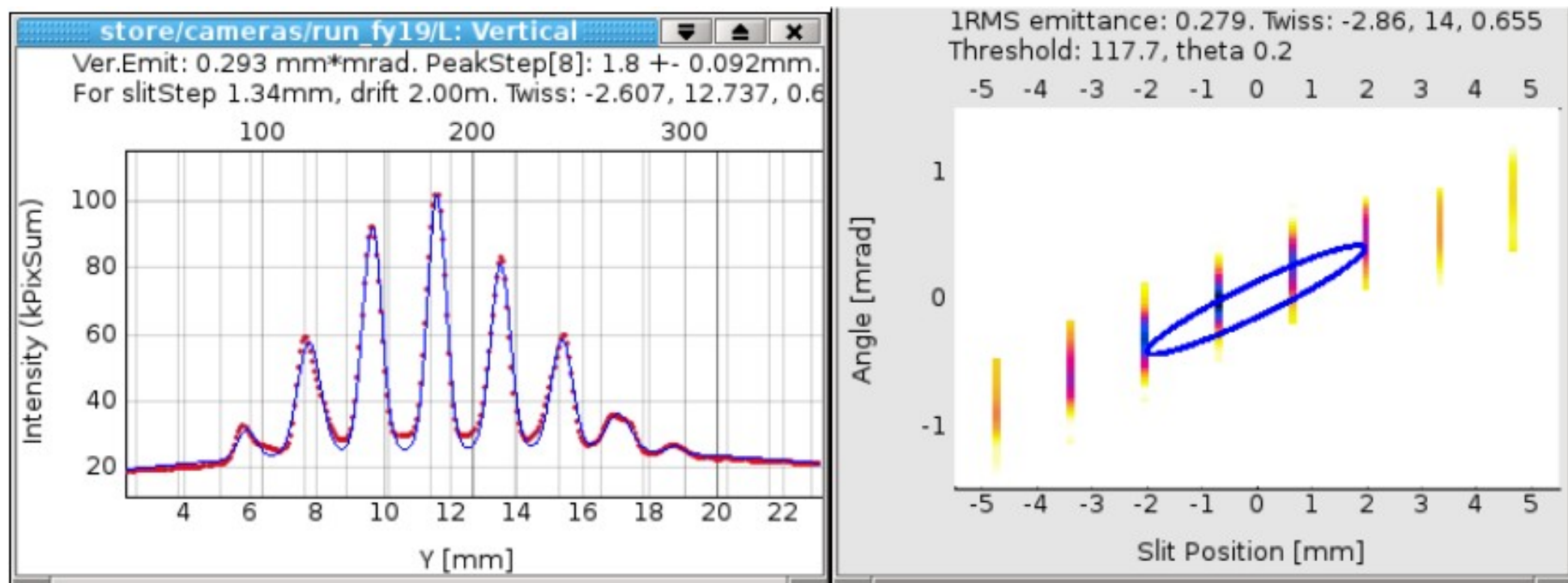
$$\beta = \frac{s^2(m)}{\epsilon} \quad (5)$$

$$\gamma = \frac{s^2(x')}{\epsilon} \quad (6)$$





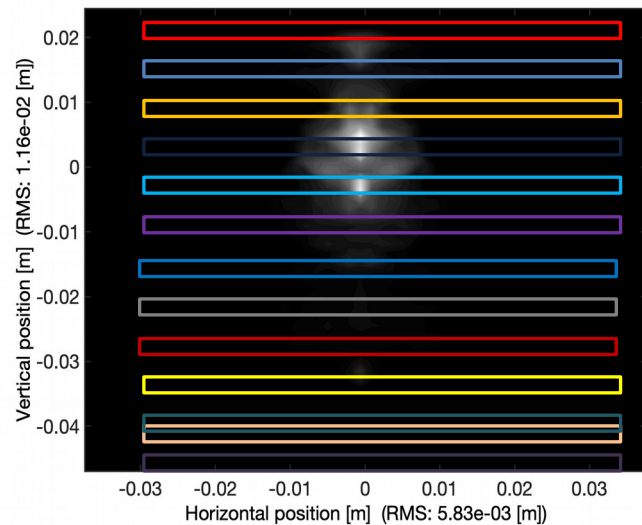
# Phase space



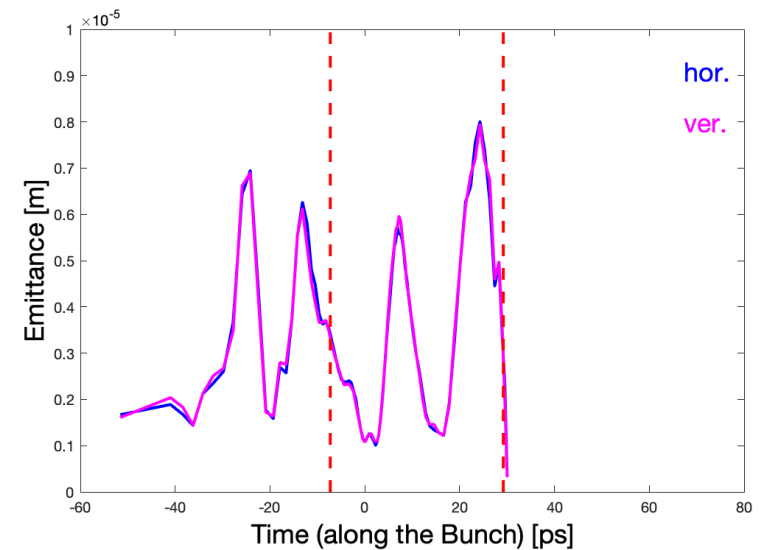
Multi-slit emittance measurement at LEReC, drift length = 2.0m  
At CEC the mask is the same, drift length = 0.93m.

# Time-resolved emittance measurement

- With TDC, Slice's emittance can be measured using standard quad scan method.



Through standard  
Quad scan method



# Emittance measurements using thick lenses and multiple quadrupoles

(by Yuan Wu)

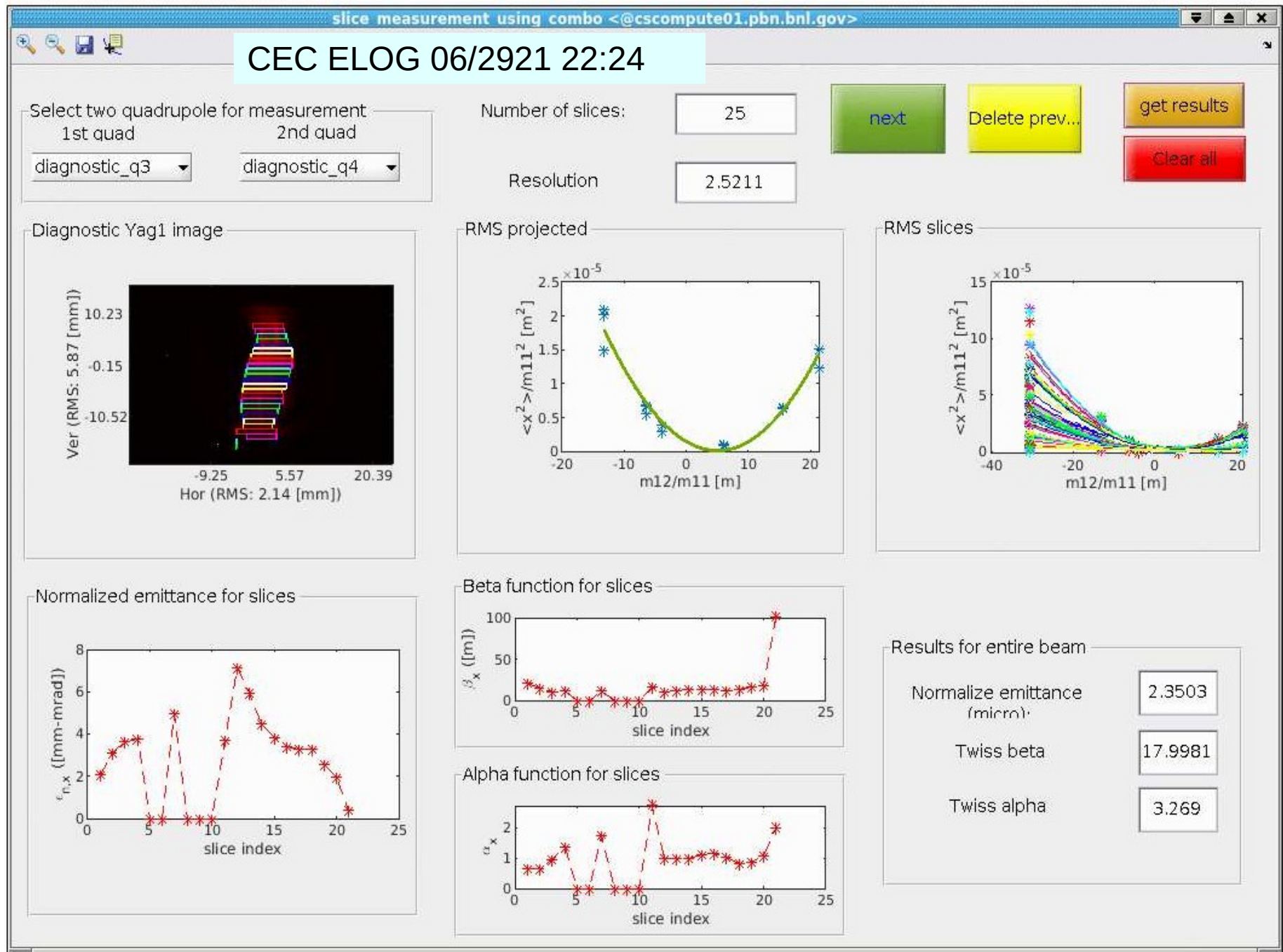
Matrix coefficients  $m_{11}$  and  $m_{12}$  have to be calculated using matrices for thick lenses and real beamline geometry. Depending of what matrix elements are not becoming zero, use of the formulae to fit parabola and calculate the beam parameters at  $s_0$ :

$$u = \frac{m_{12}}{m_{11}}; \frac{\langle x_i^2 \rangle}{m_{11}^2} = \varepsilon \left( \beta - 2u\alpha + u^2 \frac{1 + \alpha^2}{\beta} \right) = A + 2Bu + Cu^2;$$

$$A = \varepsilon\beta; B = -\alpha\varepsilon; C = \varepsilon \frac{1 + \alpha^2}{\beta}; \frac{\alpha}{\beta} = -\frac{B}{A}; \frac{A}{C} = \beta^{-2} + \left( \frac{\alpha}{\beta} \right)^2 = \beta^{-2} + \left( \frac{B}{A} \right)^2;$$

$$\beta^{-2} = \frac{A}{C} - \left( \frac{B}{A} \right)^2 \rightarrow \beta = \frac{1}{\sqrt{\frac{A}{C} - \left( \frac{B}{A} \right)^2}}; \varepsilon = \frac{A}{\beta}; \alpha = -\beta \frac{B}{A};$$

# TODO: Develop Python app from Matlab:



# Summary, Plan

- Update the application for energy spread.
- Adopt the multi-slit application for CeC.
- Develop app for zero-crossing RF phase.
- Develop app for time-resolved emittance measurement, based on Matlab code from Yuan. In first release use thin-lense approach.